MAR11-2010-001246

Abstract for an Invited Paper for the MAR11 Meeting of the American Physical Society

Focused electron beam induced deposition of magnetic nanostructures¹ JOSE M. DE TERESA, CSIC-University of Zaragoza (Spain)

Nanopatterning strategies of magnetic materials normally rely on standard techniques such as electron-beam lithography using electron-sensitive resists. Focused electron beam induced deposition (FEBID) is currently being investigated as an alternative single-step route to produce functional magnetic nanostructures. Thus, Co-based [1] and Fe-based [2] precursors have been recently investigated for the growth of magnetic nanostructures by FEBID. In the present contribution, I will give an overview of the existing literature on magnetic nanostructures by FEBID and I will focus on the growth of Co nanostructures by FEBID using $Co_2(CO)_8$ as precursor gas. The Co content in the nanostructures can reach 95% [3]. Magnetotransport experiments indicate that full metallic behaviour is displayed with relatively low residual resistivity and standard anisotropic magnetoresistance (0.8%) [3]. The coercive field of nanowires with changing aspect ratio has been determined in nanowires with width down to 150 nm by means of Magneto-optical Kerr Effect [4] and the magnetization reversal has been imaged by means of Magnetic Force Microscopy, Scanning Transmission X-ray Microscopy as well as Lorentz Microscopy experiments. Nano-Hall probes have been grown with remarkable minimum detectable magnetic flux. Noticeably, it has been found that the domain-wall propagation field is lower than the domain-wall nucleation field in L-shaped nanowires, with potential applications in magnetic logic, sensing and storage [5]. The spin polarization of these Co nanodeposits has been determined through Andreev-Reflection experiments in ferromagnetic-superconducting nanocontacts and amounts to 35% [6]. Recent results obtained in Fe-based nanostructures by FEBID using Fe₂(CO)₉ precursor will be also presented [7].

- [1] I. Utke et al., Appl. Phys. Lett. 80 (2002) 4792-4794
- [2] M. Takeguchi et al., Nanotechnology 16 (2005) 1321-1325
- [3] A. Fernández-Pacheco et al, J. Phys. D: Appl. Phys. 42 (2009) 055005
- [4] A. Fernández-Pacheco et al, Nanotechnology 20 (2009) 475704
- [5] A. Fernández-Pacheco et al, Appl. Phys. Lett. 94 (2009) 192509
- [6] S. Sangiao et al, Solid State Communications, in press
- [7] R. Lavrijsen et al, Nanotechnology, submitted

¹I acknowledge the collaboration in this field with A. Fernandez-Pacheco, R. Cordoba, L. Serrano, S. Sangiao, L.A. Rodriguez, C. Magen, E. Snoeck, L. Morellon, M.R. Ibarra.